



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IFW

re patent application of

Takashi OGURA, et al.

Serial No.: 10/561,608

Group Art Unit: 2814

Filing Date: December 20, 2005

Examiner: Pham, Hoai V.

For: SEMICONDUCTOR DEVICE AND PRODUCTION METHOD THEREFOR

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. §1.111

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the First Office Action, Restriction Requirement, and Election of Species Requirement, dated January 17, 2007. A check for the extension fee in the amount of \$120.00 is attached. A duplicate copy of this sheet is enclosed.

The Commissioner is hereby authorized to charge any deficiencies in fees or to credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,

Sean M. McGinn, Esq.
Registration No. 34,386

Date:

3/15/07

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